



JPW

Docket No. 1232-4609US1

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Kazuaki OHMI, et al.

Group Art Unit: 2812

Serial No.: 10/602,922

Examiner: Angel ROMAN

Filed: June 25, 2003

For: SEPARATING APPARATUS, SEPARATING METHOD, AND METHOD OF  
MANUFACTURING SEMICONDUCTOR SUBSTRATE

**AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Responsive to the Official Action December 21, 2004, Applicants respectfully  
request reconsideration in view of the following amendments and remarks.

**Amendments to the Claims** are reflected in the listing of claims which begins on  
page 2 of this paper.

**Remarks/Arguments** begin on page 4 of this paper.